

Docket No.: 49657-961



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Customer Number: 20277  
Kenji ITOGA, et al. : Confirmation Number: 5521  
Serial No.: 09/769,490 : Group Art Unit: 2882  
Filed: January 26, 2001 : Examiner: C. Kao  
For: X-RAY EXPOSURE APPARATUS, X-RAY EXPOSURE METHOD, X-RAY MASK, X-RAY MIRROR, SYNCHROTRON RADIATION APPARATUS, SYNCHROTRON RADIATION METHOD AND SEMICONDUCTOR DEVICE

**PETITION FOR EXTENSION OF TIME**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:


It is respectfully requested that the time for response to the Office Action dated April 13, 2004, now due to expire July 13, 2004, be extended for one (1) month and set to expire on August 13, 2004.

Please charge the extension fee of \$110.00 to Deposit Account No. 500417. Please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

08/13/2004 EABUBAK1 00000121 500417 09769490  
02 FC:1251 110.00 DA

Respectfully submitted,

MCDERMOTT WILL & EMERY LLP

  
Scott D. Paul  
Registration No. 42,984

600 13<sup>th</sup> Street, N.W.  
Washington, DC 20005-3096  
202.756.8000 SDP:kap  
Facsimile: 202.756.8087  
**Date: August 12, 2004**